

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)	Group Art Unit:
HEE JIN CHOI ET AL.)	
)	Examiner:
Serial No.:)	
)	
Filed:)	
)	
For: CONSTANT DISCHARGE STRUCTURE)	Los Angeles, California
FOR NOZZLE HEAD LOWERING TYPE)	
VACUUM COSMETICS CONTAINER)	

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of
Patents and Trademarks
Alexandria, VA 22313

Sir:

Attached hereto is a PTO-1449 form listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and an initialed copy of each page of the form be returned to the undersigned.

It should be noted the word "prior" has been deleted from the form.

It is believed that this disclosure complies with the requirements of 37 C.F.R. § 1.56 and the Manual of Patent Examining Procedure § 707.05(b). If, for some reason, the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

These documents are not necessarily analogous art.

Respectfully submitted,

Park & Sutton LLP

Dated: 2/18, 2004

By: 

JOHN K. PARK
Regis. No. 37,904

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO. 1811.01

SERIAL NO.

LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)

APPLICANT: Hee Jin Choi et al.

FILING DATE: Herewith

GROUP

U.S. PATENT DOCUMENTS

Examiner Initial		DOCKET NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	NONE					
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						
	AR						

FOREIGN PATENT DOCUMENTS

		DOCKET NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AS	10-1998-0702906	4/22/98	Republic of Korea			X	
	AT							
	AU							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

	AV	NONE
	AW	
	AX	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.